## **Supporting information**

## **Co-doped modified LiLuF**<sub>4</sub>:Eu microcrystalline scintillation with flexible film for high resolution X-ray imaging

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Scintillators	The detection limit [nGy s <sup>-1</sup> ]	References
LiYbF <sub>4</sub> :Tb NCs	360	[1]
$[TPPen]_2Mn_{0.9}Zn_{0.1}Br_4$	204.1	[2]
[FEtQ] <sub>2</sub> MnBr <sub>4</sub>	258	[3]
$K_2CuBr_3$	132.82	[4]
Cs <sub>2</sub> AgBiCl <sub>6</sub>	241	[5]
LiLuF4:Eu,Gd	140.72	This work

Table S1. Comparison of the detection limit of reported scintillators

References: [1] CrystEngComm, 2022, 24, 2551–2557. [2] Adv. Optical Mater. 2023, 2300330. [3] Adv. Funct. Mater. 2021, 31, 2102848. [4] ACS Appl. Electron. Mater. 2020, 2, 2242–2249. [5] ACS Appl. Electron. Mater. 2022, 4, 4530–4539.



Fig. S1 XRD patterns of LiLuF<sub>4</sub>:x%Eu MCs with different  $Eu^{3+}$  contents.



Fig. S2 XRD patterns of LiLuF<sub>4</sub>:9%Eu,x%Gd MCs with different Gd<sup>3+</sup> contents.



Fig. S3 Partial SEM image of LiLuF<sub>4</sub>:9%Eu MCs (a) and LiLuF<sub>4</sub>:9%Eu,12%Gd MCs (b).



Fig. S4 The EDS of the LiLuF<sub>4</sub>:9%Eu,12%Gd MCs.



Fig. S5 Full XPS spectra of (a) LiLuF<sub>4</sub>:9%Eu,12%Gd MCs and high-resolution XPS spectra of (b) Eu 3d, (c) Lu 4d, (d) Gd 4d.



Fig. S6 The excitation spectrum of LiLuF<sub>4</sub>:9%Eu and LiLuF<sub>4</sub>:9%Eu,12%Gd MCs.



Fig. S7 Photoluminescence decay spectra of  $LiLuF_4$ :9%Eu (top) and  $LiLuF_4$ :9%Eu,12%Gd (bottom).



Fig. S8 X-ray luminescence spectra of  $LiLuF_4$ :x%Eu and BGO at X-ray dose rate 42.29 mGy/s.



Fig. S9 X-ray luminescence spectra of LiLuF<sub>4</sub>:x%Gd,9%Eu and BGO at X-ray dose rate 42.29 mGy/s.



Fig. S10 The radioluminescence spectra of  $BaF_2$  (a) and BGO (b) at a voltage of 50kV and a dose rate of 8.198mGy/s~42.293 mGy/s.



Fig. S11 Attenuation efficiencies as a function of the material thickness of  $LiLuF_4$  and several scintillators to 50 keV X-ray photons.



Fig. S12 The energy level transition process of Eu<sup>3+</sup> and Gd<sup>3+</sup>.



Fig. S13 Schematic diagram of preparation process of LiLuF<sub>4</sub>:9%Eu,12%Gd MCs-EP composite scintillating film.



Fig. S14 The physical image of 50wt% LiLuF<sub>4</sub>:9%Eu,12%Gd scintillation film.



Fig. S15 The grain distribution of LiLuF<sub>4</sub>:9%Eu,12%Gd film observed under a microscope.



Fig. S16 The grayscale image at 10-20 LP/mm of LiLuF4:9%Eu,12%Gd scintillation film.



Fig. S17 The stripe brightness extraction map of LiLuF<sub>4</sub>:9%Eu,12%Gd film at 10-16 LP/mm.



Fig. S18 Modulation transfer functions (MTF) of the X-ray edge image obtained by  $LiLuF_4$ :9%Eu film.